

Notice of References Cited	Application/Control No. 10/501,694		Applicant(s)/Patent Under Reexamination VAN DER VLEUTEN ET AL.	
	Examiner Seokyun Moon		Art Unit 2629	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0142504	10-2002	Feldman et al.	438/30
*	B	US-5,402,149	03-1995	Amagami et al.	345/698
	C	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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